



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasuhiro OMURA et al.

Group Art Unit: 2851

Application No.: 09/769,832

Examiner: R. E. Fuller

Filed: January 26, 2001

Docket No.: 108455

For: PROJECTION EXPOSURE APPARATUS AND METHOD, CATADIOPTIC
OPTICAL SYSTEM AND MANUFACTURING METHOD OF DEVICES

PRELIMINARY AMENDMENT AND
RESPONSE TO RESTRICTION REQUIREMENT

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

In response to the Restriction Requirement dated August 30, 2002, and prior to
examination on the merits, please amend the above-identified application as follows:

IN THE ABSTRACT:

Please replace the Abstract filed with the substitute Abstract attached hereto.

REMARKS

Claims 1-66 are pending. In this response, the Abstract is amended in accordance
with M.P.E.P. §608.01(b). No new matter has been added. The attached Appendix includes
a marked-up copy of the Abstract (37 C.F.R. §1.121(b)(1)(iii)).

I. RESPONSE TO RESTRICTION REQUIREMENT

In reply to the August 30, 2002 Restriction Requirement, Applicants provisionally
elect Group I, claims 1-48, with traverse.

It is respectfully submitted that the subject matter of all claims 1-66 is sufficiently
related that a thorough search for the subject matter of any one Group of claims would
encompass a search for the subject matter of the remaining claims. Thus, it is respectfully

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